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INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	Applicant: Richard J. MCCURDY, et al.	
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U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
		5,514,454	05/1996	Boire et al.			

FOREIGN PATENT DOCUMENTS

		Document	Date	Country	Class	Sub-class	Translation Yes/No
	✓	JP Kokai (A) 63-100042	05/1988	Japan			

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

	Hass, "Oxide Layers Deposited from Organic Solutions, Physics of Thin Films," Academic Press, New York and London, (1969) Volume 5, pp. 87 and 105-115
✓	Watanabe et al., "Photocatalytic Activity of TiO2 Thin Film under Room Light, Photocatalytic Purification and Treatment of Water and Air, (1993), pp. 747-751
✓	Kamata et al., "Rapid formation of TiO_2 films by a conventional CVD method," Journal of Materials Science, Letters 9, (1990) pp. 316-319, Chapman and Hall Ltd.

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